

AF/2800

Attorney's Docket No.: 10417-101001 / F51-136645M/TOM



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haruo Hyodo et al.                      Art Unit : 2822  
Serial No. : 09/963,267                              Examiner : Ida M. Soward  
Filed : September 26, 2001  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

*entry  
approved*

**BOX AF**  
Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT TO OFFICE OFFICE DATED DECEMBER 20, 2002

In response to the action mailed December 20, 2002, please amend the application as follows:

*1/11/03*  
*amdt*  
*RECEIVED*  
*3/28/03*  
*136645*

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

MARCH 20, 2003  
Date of Deposit  
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